AlGaInP optical source integrated with fiber links and silicon avalanche photo detectors in fiber optic systems

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ABSTRACT

This study has clarified aluminium gallium indium phosphide (AlGaInP) optical source integrated with fiber links and silicon avalanche photodetectors in fiber optic systems. The output spectral power, rise time, signal frequency and resonance frequency for AlGaInP laser diode. The laser diode rise time, output spectral power and resonance/signal frequencies versus injection current and ambient temperatures are sketched. The silica doped germanium fiber link pulse broadening and the signal fiber bandwidth are investigated against temperature variations. The signal per noise ratio is related to Q value and bit error rate (BER) at the receiving point (Si avalanche photodetector (APD)) are sketched with temperature.

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1. INTRODUCTION

The resulting signals become unrecognizable as individual information bits and the accurate detection of the original data signals become difficult at the receiver end which demodulates the optical signals into their original transmitted pulses [1]-[7]. The optical amplifiers are then required in very long transmission links to boost and amplify the weak and distorted optical signals for accurate retrieving of original signal in the receiver stage [8]-[15]. At the receiver end, the optical signals are detected and converted back into electrical signals by a light sensitive device known as a light detector or a photodetector (PD) like avalanche photodetector (APD) [16]-[23]

The optical transmitter unit is a transducer. It is composed of optical source and the driver circuit [24]-[27]. It converts the electrical input signals into corresponding light signals and launches them into the optical fiber. The light emitting diodes (LEDs) and laser diodes (LDs) are solid state semiconductor devices [28]-[33]. They are fabricated from different semiconductor materials which enable the designer to determine the emission wavelength. The gallium aluminum arsenide (GaAlAs) laser can emit the wavelengths range between 0.8 to 0.9 μ m while the indium gallium arsenide phosphide (InGaAsP) laser can emit the wavelength range between 1.0 and 1.6 μ m. Both LEDs and LDs can be modulated directly [34]-[39].

They enhance the optical communication systems and networks. The performance enhancement has been achieved through three directions of methodologies for thesis researches. The first methodology has been performed through performance considerations evaluation for different vertical cavity surface emitting

lasers (VCSEL) structures and various electro-optic modulators types under influences of different spectral and thermal changes to determine the more effective VCSEL structure and better electro-optic modulator type [40]-[49].

This work has concentrated on AlGaInP optical source integrated with fiber links and silicon avalanche photodetectors in fiber optic systems. The output spectral power, rise time, signal frequency and resonance frequency for aluminium gallium indium phosphide (AlGaInP) laser diode. The laser diode rise time, output spectral power and resonance/signal frequencies versus injection current and ambient temperatures are sketched. The silica doped germanium fiber link pulse broadening and the signal fiber bandwidth are investigated against temperature variations. The signal per noise ratio is related to Q value and BER at the receiving point.

2. CIRCUIT DESCRIPTION AND RESEARCH METHOD

The output power (P₀) and applied bias voltage voltage for the laser diodes are given by [8]-[19]:

$$P_0 = 22.65 - 3.65 V + 1.543 V^2 - 0.07654 V^3$$
(1)

$$V = 2.18755 + 0.113597 I - 0.003626 I^2 + 0.0004816 I^3$$
(2)

With I is the injection current which is modeled by a function of ambiemnt temperature (K) as [8], [20]-[28]:

$$I = a_0 + a_1 T + a_2 T^2 + a_3 T^3$$
(3)

Where for AlGaInP laser diode, the values are $a_0=0.4321$, $a_1=10.54x10^{-4}$, $a_2=1.324x10^{-9}$, and $a_3=0.8764x10^8$. Where the laser diode bandwidth (f_{3-dB}), its rise time (τ), and its resonance frequency (f_r), are cast by the mathematical formulas [10, 11-22]:

$$f3 - dB = b_0 + b_1 I + b_2 I^2 \tag{4}$$

$$\tau = c_0 + c_1 I + c_2 I^2 \tag{5}$$

$$fr = d_0 + d_1 I + d_2 I^2 \tag{6}$$

All the basic coefficients b_0 , b_1 , b_2 , c_0 , c_1 , c_2 , and d_0 , d_1 , d_2 , of f_{3-dB} , τ and f_r versus temperature T for AlGaInP laser diode are listed in the series of equations as the following [10], [23]-[33]:

$$b_0 = 1.43 - 0.976 T - 0.08765 T^2$$

$$b_1 = 1.546 - 0.0876 T - 0.7654 T^2$$

$$b_2 = 1.59 - 0.0876 T + 0.07636 T^2$$
(7)

$$c_0 = 0.87 - 3.685 T - 0.0654 T^2$$

$$c_1 = -3.65 + 1.321 T - 1.654 T^2$$

$$c_2 = 33.65 - 3.165 T + 0.0543 T^2$$
(8)

$$d_0 = 2.987 - 0.765 T - 0.7659 T^2$$

$$d_1 = 00655 - 1.076 T + 3.765 T^2$$

$$d_2 = 6.543 + 0.327 T - 0.43298 T^2$$
(9)

For the silica doped germanium with fiber link refractive index can be modeled by the following formula [8], [9], [30]-[39]:

$$n = \sqrt{\frac{h_1\lambda^2}{\lambda^2 - h_2^2} + \frac{h_3\lambda^2}{\lambda^2 - h_4^2} + \frac{h_5\lambda^2}{\lambda^2 - h_6^2}} ,$$
(10)

Where all the basic coefficients for the fiber link are cast as the following formulas:

$$h_{1} = 0.8765 \left(\frac{T}{T_{0}}\right) \left(\frac{x}{0.054}\right)$$

$$h_{2} = 1.2323 \left(\frac{T}{T_{0}}\right)^{2}$$

$$h_{3} = 5.654 \left(\frac{T}{T_{0}}\right) \left(\frac{x^{2}}{3.539}\right)$$
(11)

$$h_{1} = 1.986 \times 10^{4} \left(\frac{T}{T_{0}}\right) \left(\frac{1.54}{2.2 x}\right)$$

$$h_{2} = 0.0432 \left(\frac{T}{T_{0}}\right)^{2}$$

$$h_{3} = 0.00654 \left(\frac{T}{T_{0}}\right) \left(\frac{x^{3}}{7.876}\right)$$
(12)

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Where T_0 is the room temperature and x the percentage dopant ratio from germanium added to silica fiber link. The soliton transmission techniques based on the soliton peak power with the following expression [10]-[14], [20]-[29]:

$$P_1 = \frac{\lambda \lambda^3 D_t A_{eff}}{4\pi^2 c n_2 \Delta \tau^2} , \tag{13}$$

Where n_2 is the nonlinear coefficient in m^2 /Watt, D_t is total dispersion factor, A_{eff} is the cross section effective area for optic fiber link, and then by using (13), the total pulse broadening, and total signal bandwidth are estimated by [9], [10], [12]-[20]:

$$\Delta \tau = \sqrt{\frac{\Delta \lambda^3 D_t A_{eff}}{4\pi^2 P_1 n_2 c}} \tag{14}$$

$$BW_{Sig.} = \frac{0.44}{\Delta\tau L} \tag{15}$$

The sig./noise ratio with the signal quality and BER at the receiving point expressed by [9]-[11], [13]-[20]:

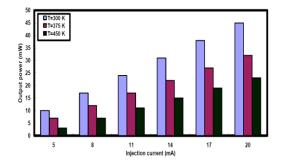
$$SNR = \frac{(GP_R\rho)^2 R_L}{4kTB.W_{sig} + 2eR_I B.W_{sig} G^n (l_d + \rho P_R)},$$
(16)

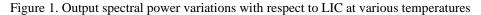
$$(SNR)_{dB} = 10 \log S NR \quad , \tag{17}$$

$$BER = 0.5[1 - erf(0.345 SNR)]$$
(18)

3. DISCUSSION

We have analyzed the quadrature semiconductor light source integrated with silica doped germanium fiber link in the complete matching silicon avalanche photodetectors. The output spectral power, resonance frequency, laser diode frequency bandwidth and laser diode rise time are analyzed and discussed. As well as the total pulse broadening, fiber signal bandwidth is also analyzed by using a Soliton transmission scheme-based fiber communication links. The sig./noise ratio and BER are investigated through the silicon avalanche photodetector or optical receiver side. All the obtained results are depending on the following parameters such as Ambient temperature $300 \le T$, K ≤ 425 , P₁=100 mW, photodetector responsivity ρ =0.9 A/W, I_d=10 nA, Fiber link=10 km, R_L=100 K Ω , G=2 for photodetector, λ =1550 nm, germanium doped ratio (x), $0.1 \le x \le 0.3$, and Injection current (I), $5 \le I$, mA ≤ 20 . As shown in Figure 1, the output spectral power variations with respect to laser injection current (LIC) at various ambient temperatures. The obtained result is assured that the increase of the injection current, results in the increase of the output spectral power of the laser. The output power at both the LIC of 5 mA and 300 K is 10 mW. The output power at both the LIC of 20 mA and 300 K is 45 mW. Figure 2 clarifies the laser signal frequency variations versus LIC variations at various ambient temperatures. The laser signal frequency increases with injection current increases. The laser signal frequency at both the LIC of 5 mA and 300 K is 12 GHz. The laser signal frequency at both the LIC of 20 mA and 300 K is 77 GHz. The higher the injection laser current the higher laser signal frequency.





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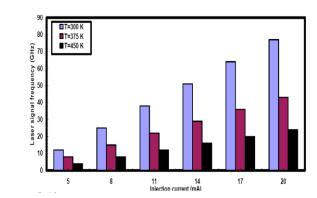


Figure 2. Laser signal frequency variations versus LIC variations at various temperatures

Figure 3 illustrates the laser rise time variations versus LIC variations at various temperatures. The laser rise time at both the laser current of 5 mA and 300 K is 10 ns. The laser rise time increases with the increase of the injection current. The laser rise time at both the LIC of 20 mA and 300 K is 320 ns. The higher the laser rise time.

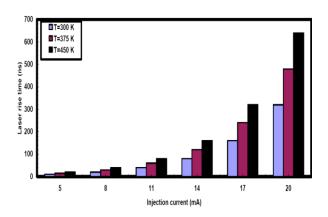


Figure 3. Laser rise time variations versus LIC variations at various temperatures

Figure 4 shows the laser resonance frequency variations versus LIC variations at various ambient temperatures. The laser resonance frequency increases with the increase of the injection current. The laser resonance frequency at both the LIC of 5 mA and 300 K is 25 GHz. The laser resonance frequency at both the LIC of 20 mA and 300 K is 60 GHz. The higher the LIC the higher laser resonance frequency. Table 1 summarizes the results of Figures 1, 2, 3, and 4 for the laser performance parameters under min/max injection current variations at various temperatures.

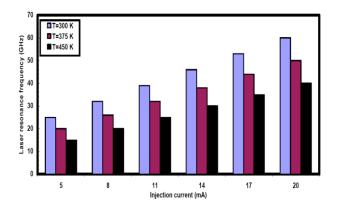


Figure 4. Laser resonance frequency variations versus LIC variations at various ambient temperatures

Table 1. Laser performance parameters under min/max injection current variations at various temperatures

Laser performance parameters	5 mA injection current			20 mA injection current		
	300 K	375 K	450 K	300 K	375 K	450 K
Output power (mW)	10	7	3	45	32	23
Laser frequency (GHz)	12	8	4	77	43	24
Laser rise time (ns)	10	15	20	320	480	640
Laser resonance frequency (GHz)	25	20	15	60	50	40

Figure 5 clarifies the fiber channel pulse broadening in relation to ambient temperature at different germanium dopant ratios. The fiber pulse broadening decreases with increasing the germanium dopant ratio and adjust the temperature at room temperature. The fiber channel pulse broadening at both the germanium dopant ratio of 0.1 and a room temperature of 300 K is 320 ns. The fiber channel pulse broadening at both the germanium dopant ratio of 0.1 and an ambient temperature of 450 K is 500 ns. The higher the dopant ratio in the fiber the lower the fiber pulse broadening. Figure 6 shows the fiber channel bandwidth in relation to ambient temperature at different germanium dopant ratios. The fiber channel bandwidth increases with the increase of the germanium dopant ratio and adjusts the temperature at room temperature. The fiber channel bandwidth at both the germanium dopant ratio of 0.1 and a nome temperature of 3.1 and a nome temperature of 3.1 and a room temperature of 3.2 k is 5.2 k. The fiber channel bandwidth at both the germanium dopant ratio of 0.1 and a nome temperature of 3.2 k is 5.2 k. The fiber channel bandwidth at both the germanium dopant ratio of 0.1 and a nome temperature of 3.2 k is 5.2 k. S fiber channel bandwidth at both the germanium dopant ratio of 0.1 and a nome temperature of 3.2 k is 5.2 k. S fiber channel bandwidth at both the germanium dopant ratio of 0.1 and an ambient temperature of 4.5 k is 5.2 k. S fiber channel bandwidth at both the germanium dopant ratio of 0.1 and an ambient temperature of 4.5 k is 5.2 k. S fiber channel bandwidth at both the germanium dopant ratio of 0.1 and an ambient temperature of 4.5 k is 5.2 k. S fiber channel bandwidth at both the germanium dopant ratio of 0.1 and an ambient temperature of 4.5 k is 5.2 k. S fiber channel bandwidth at both the germanium dopant ratio of 0.1 and an ambient temperature of 4.5 k is 5.2 k. S fiber channel bandwidth.

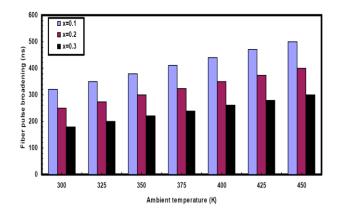


Figure 5. Fiber channel pulse broadening with temperature at different germanium dopant ratios

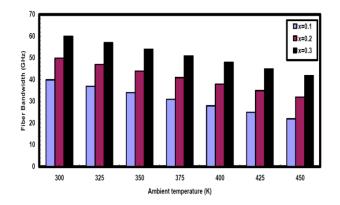


Figure 6. Fiber channel bandwidth with temperature at different germanium dopant ratios

Figure 7 clarifies the signal per noise ratio with the temperature at different germanium dopant ratios based optical receivers. The signal per noise ratio increases with the adjust the temperature at 300 K and the germanium dopant ratio at 0.3. The sig./noise ratio at both the germanium dopant ratio of 0.1 and a room temperature of 300 K is 30 dB. The signal per noise ratio at both the germanium dopant ratio of 0.1 and a nambient temperature of 450 K is 12 dB. The higher the dopant ratio in the fiber the lower the sig./noise ratio. Figure 8 shows the BER against ambient temperature at different germanium dopant ratios based optical receivers. The data error rates decrease with the adjust the temperature at 300 K and the germanium dopant ratio at 0.3. The higher the dopant ratio in the fiber the BER at the receiver side. Table 2

summarizes the results of Figures 5, 6, 7 and 8 for the Table 2 Fiber/Photodetector performance parameters under min./max temperature variations at various germanium dopant ratios.

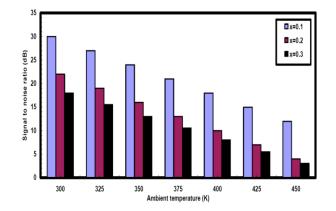


Figure 7. Signal per noise ratio variations with the temperature at various germanium dopant ratios based optical receivers

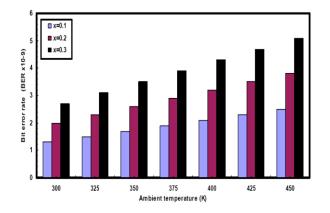


Figure 8. Data rate against temperature at various germanium dopant ratios based optical receivers

 Table 2. Fiber/Photodetector performance parameters under min./max temperature variations at various germanium dopant ratios

germanian dopant ratios											
Fiber/Photodetector performance	300 K room temperature			450 K ambient temperature							
parameters	10 %	20 %	30 %	10 %	20 %	30 %					
	dopant	dopant	dopant	dopant	dopant	dopant					
Fiber pulse broadening (ns)	320	250	180	500	400	300					
Fiber bandwidth (GHz)	40	50	60	22	32	42					
Signal to noise ratio at receiver (dB)	30	22	18	12	4	3					
Bit error rate (BER x 10 ⁻⁹)	1.3	2	2.7	2.5	3.8	5.1					

4. CONCLUSION

AlGaInP laser diode source integrated with silica doped germanium fiber link and Si APD optical receivers are investigated in detail. The laser diode output spectral power, laser rise time, laser resonance frequency, laser signal bandwidth is sketched versus both injection current and ambient temperatures. The silica doped fiber link bandwidth and fiber link pulse width broadening are analyzed against temperature variations. The sig./noise ratio and data error rates at the receiver point are investigated against temperature variations. The obtained results are enhanced with room temperature and average injection current value of 10 mA. The fiber link performance is upgraded with the increase dopant ratio of germanium up to 30% added to the silica fiber link.

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